AUG 2.4 2005

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(use as many sheets as necessary)

Complete if Known		
Application Number	09/848,914	
Filing Date	May 4, 2001	
First Named Inventor:	William B. Chapman et al.	
Art Unit	2828	
Examiner Name	Rodriguez, Armando	

Sheet	1	of 1 Attorney Docket Number 42P1	4870	
		NON PATENT LITERATURE DOCUMENTS		
Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published		
AL	1	ZHANG, et al., "An Interference Filter Based External Cavity Laser For Dense Wavelength Division Multiplexing Applications", Corning OCA Corporation, pgs. 1-6.		
AR	2	TAKASHASHI, H., "Temperature Stability of Thin-Film Narrow-Bandpass Filters Produced by Ion-Assisted Deposition", Applied Optics, Vol. 34, No. 4, pgs. 667-675, Feb. 1, 1995, Supplied by the British Library - "the worlds knowledge" www.bl.uk		
AL	3	MELLIS et al., "Miniature Packaged External-Cavity Semiconductor Laser with 50 GHz Continuous Electrical Tuning Range", Electronics Letters Vol. 24 No. 16, pgs. 988-989, April 22, 1988, Supplied by the British Library - "the worlds knowledge" www.bl.uk		
AN	4	SCOBEY & STUPIK, "Stable Ultra-Narrow Bandpass Filters", SPIE, Vol. 2262, pgs. 37-46. Supplied by the British Library - "the worlds knowledge" www.bl.uk		
An	5	ROSENBERG, K.P., et al., "Logarithmically Variable Infrared Etalon Filters", SPIE Vol. 2262, pgs. 223-232, Supplied by the British Library - "the worlds knowledge" www.bl.uk		
All	6	FAVRE, et al., "External-Cavity Semiconductor Laser With 15nm Continuous Tuning Range", Electronics Letters, Vol. 22, No. 15, pgs. 795-796, June 17 1996, Supplied by the British Library- "the worlds knowledge" www.bl.uk		
SL	7	MACLEOD, H. A., "Thin Film Optical Filters", 2nd Edition, McGraw-Hill, 1989, pgs. 244-269, Supplied by the British Library - "the worlds knowledge" www.bl.uk		

Examiner Signature Armando Políticaro Consi	dered //-/8-05
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^{*}Examiner: Initial if reference considered, whether or not citation is in comformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English Translation is attached.

This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or